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Date of Signature and Deposit: January 14, 2004

Adam J. Fenn  
Attorney of Record

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Mark A. Lucak  
Serial No.: 09/843,563  
Filed: 04/26/01  
Examiner: Coleman, William D.  
Group Art Unit: 2823  
Docket No.: 00AB179  
Title: *Method for Fabricating a Microelectromechanical System (MEMS) Device Using a Pre-Patterned Substrate*

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RESPONSE TO FINAL OFFICE ACTION

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Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA, 22313-1450

Dear Sir:

In response to the Final Office Action dated October 14, 2003, please amend the above-identified patent application as follows: